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				Application Number	Herewith
				Filing Date	
				First Named Inventor	Chen et al
				Group Art Unit	
				Examiner Name	
Sheet	1	of	6	Attorney Docket Number	100202586-5

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cita No.†	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code* (# known)			
		20020079432	A1	Lee et al.	06-27-2002	
		20020075554	A1	Brophy et al.	06-20-2002	
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Sheet	3	of	6	Attorney Docket Number	100202586-5

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
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Notice of References Cited	Application/Control No. 10/280,995		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Jack Dinh		Art Unit 2873	6 of 6

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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X	B	US-2002/0196548	12-2002	Fabiny, Larry	359/571
	C	US-			
	D	US-			
	E	US-			
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